New PCT National Stage Application Docket No. 14010-000008/US

## IAP20 Rec'd PCT/PTO 16 DEC 2005

## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant(s):

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Masaru KARIYAMA

Int'l App. No.:

PCT/JP2003/007765

Application No.:

**NEW APPLICATION** 

Filed:

December 16, 2005

For:

SEMICONDUCTOR DEVICE AND

MANUFACTURING METHOD FOR THE SAME

(as amended)

## **PRELIMINARY AMENDMENT**

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Mail Stop PCT

December 16, 2005

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application. Prior to examination of the present application, please consider the following:

Amendments to the Title begin on page 2 of this Preliminary Amendment.

Amendments to the Claims begin on page 3 of this Preliminary Amendment.

## **AMENDMENTS TO THE TITLE**

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Please note that Applicant has amended the title of the present application to read as follows:

"SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD FOR THE SAME"